



DOCKET: CU-2636

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Sang Ick LEE et al.]
Serial No.: 09/994,284] Group Art Unit: 2823
Filed: 26 November 2001] Examiner: Pham, Thanh V.
For: METHOD OF FORMING METAL]
GATE IN SEMICONDUCTOR]
DEVICE]



Certification under 37 C.F.R. §1.8(a)

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with The United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, on July 17, 2003.

Vangelis Economou
Vangelis Economou – Reg. No. 32,341

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION AND FEE FOR EXTENSION OF TIME (37 CFR 1.136 (a))

Sir:

This is a petition for an extension of time for a period of one month in which to respond to the Official Action dated March 25, 2003, extending the period for response from June 25, 2003 until July 25, 2003.

Enclosed please find a check in payment of the Fee for this Petition for an Extension of Time for two months, total in the amount of \$110.00. If there are any additional fees, please charge Deposit Account No. 12-0400.

Respectfully submitted,



July 17, 2003

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